

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cleeves et al.	
Application No.: 10/681,509	Group Art Unit: 2814
Filed: 10/07/2003	Examiner: Howard Weiss
Title: Uniform Seeding to Control Grain and Defect Density of Crystallized Silicon for Use in Sub-Micron Thin Film Transistors	
Attorney Docket No.: SAND- 01135US0 (formerly MA-108)	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	December 22, 2006

PETITION UNDER 37 CFR 1.182: CHANGE ORDER OF INVENTOR NAMES

Applicants, through their undersigned agent, hereby petition the Commissioner to change the order of the names of the inventors in the above-identified application. The prior order of inventor names was made in error in an application data sheet filed with the application. The actual inventors are not changed, and no inventors are added or removed. Only the order of the names is intended to be changed.

The **INTENDED** order of the inventor names, which appears on the original declaration as filed, is as follows:

(1) Shuo Gu

(2) James M. Cleeves

The petition fee set forth in 37 C.F.R. §1.17(f) is provided in the amount of:
\$400.00.

An application data sheet including inventor names in the correct order is
included.

December 22, 2006
Date

/Pamela J. Squyres/
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